

Docket No.: 4590-340

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	EXPEDITED PROCEDURE
	:	Response under 37 CFR 1.116
	:	
Pierre-Olivier LEFORT et al.	:	Confirmation No. 6495
	:	
U.S. Patent Application No. 10/510,385	:	Group Art Unit: 2813
	:	
Filed: October 6, 2004	:	Examiner: Nguyen, Thanh T.
For: PROCESS FOR FABRICATING A MICROSTRUCTURE CONTAINING A VACUUM CAVITY, AND MICROSTRUCTURE		

**AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111**

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Commissioner for Patents  
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Sir:

This paper is submitted in reply to the non-final Office Action mailed April 24, 2008.

**Amendments to the Claims** – page 2.

**Remarks/Arguments** - page 4.